Electronic Supporting Information

Oxidation Promoted Self-Assembly of π -Conjugated Polymers

Garion E. J. Hicks, Charles N. Jarrett-Wilkins, Jenny R. Panchuk, Joseph G.

Manion, and Dwight S. Seferos*

Lash Miller Chemical Laboratories, Department of Chemistry, University of

Toronto, 80 St. George Street, Toronto, Ontario, M5S 3H6, Canada

Table of Contents

Figure S1. ¹ H NMR spectrum of Thiophene Monomer	S3
Figure S2. ¹ H NMR spectrum of Tellurophene Monomer	S4
Figure S3. ¹ H NMR spectrum of PTh ₈₀ - <i>b</i> -PTe ₆₀	S5
Figure S4. GPC traces of block copolymer PTh ₈₀ - <i>b</i> -PTe ₆₀	S6
Figure S5. PTe Homopolymer Solid State Optical Absorption Spectrum	S7
Figure S6. UV-Vis-NIR of Oxidized PTh ₈₀ - <i>b</i> -PTe ₆₀ .	S8
Figure S7. STEM of Partially Aggregated PTh ₈₀ - <i>b</i> -PTe ₆₀	S9
Figure S8. TEM of Oxidized PTh ₈₀ - <i>b</i> -PTe ₆₀	S10
Figure S9. Oxidized PTh ₈₀ - <i>b</i> -PTe ₆₀ Micelle Widths measured by AFM	S11
Figure S10. PTh ₈₀ -b-PTe ₆₀ 15 min after FeTs ₃ addition	S12
Figure S11. Size Distribution of Oxidized Micelles Aged for 2 months	S13
Figure S12. STEM of Oxidized Micelles Aged for 2 months	S14
Figure S13. WAXS of Partially Aggregated (blue) and Oxidized PTh ₈₀ - <i>b</i> -PT (red) samples.	
Figure S14. UV-Vis-NIR Spectroscopy of Oxidized (red trace) and Reduced <i>b</i> -PTe ₆₀ (blue trace).	
S1. Work Function Calculation for Oxidatively Doped PTe Films	S17
Table S1. Differences in work function and conductivities of PTe thin films doped with FeTs ₃	-
References	S18

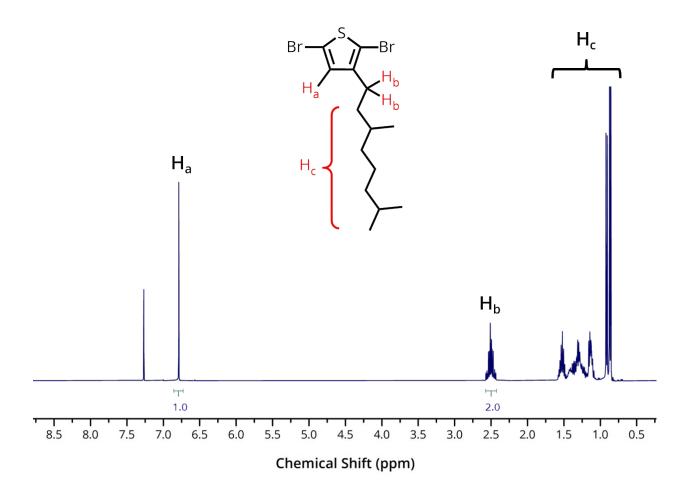


Figure S1. ¹H NMR spectrum of Thiophene Monomer in CDCl₃ at 25 °C, 500 MHz.

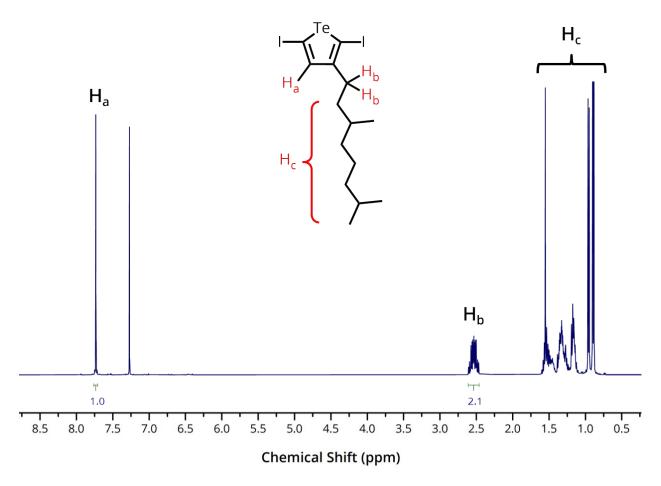


Figure S2. ¹H NMR spectrum of Tellurophene Monomer in CDCl₃ at 25 °C, 500 MHz.

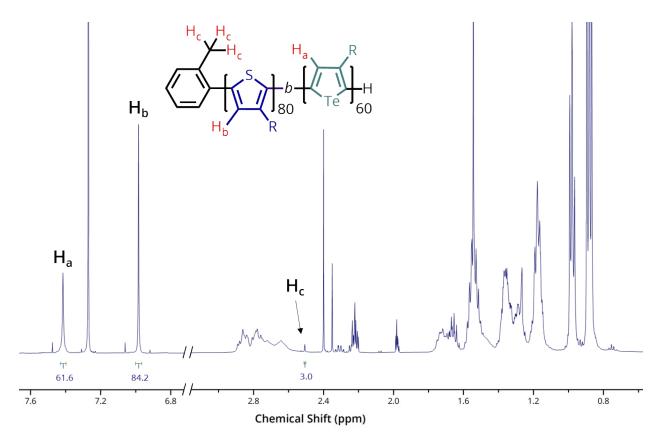


Figure S3. ¹H NMR spectrum of PTh₈₀-*b*-PTe₆₀ in CDCl₃ at 25 °C, 500 MHz.

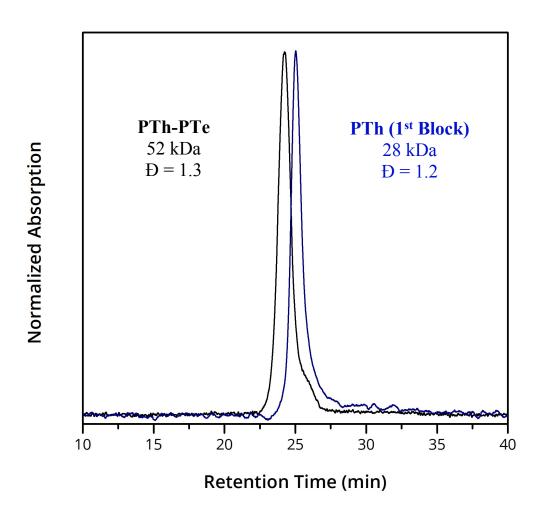


Figure S4. GPC traces of block copolymer PTh_{80} -*b*- PTe_{60} . M_n overestimation by a factor of 1.2 is typical due to the rigidity of polymer semiconductors relative to polystyrene standards.¹

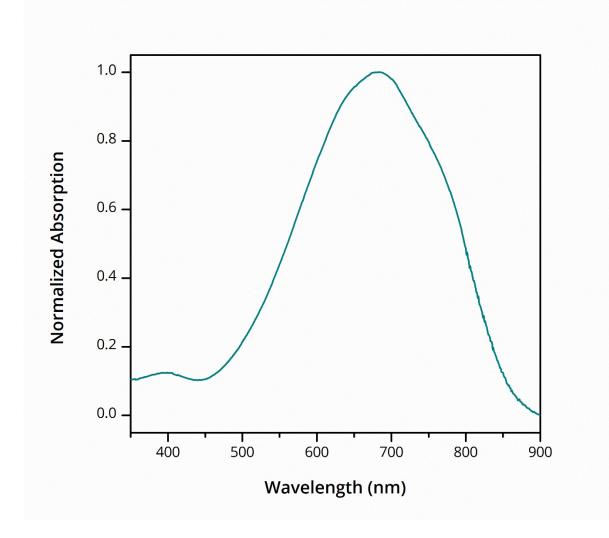


Figure S5. PTe Homopolymer Solid State Optical Absorption Spectrum

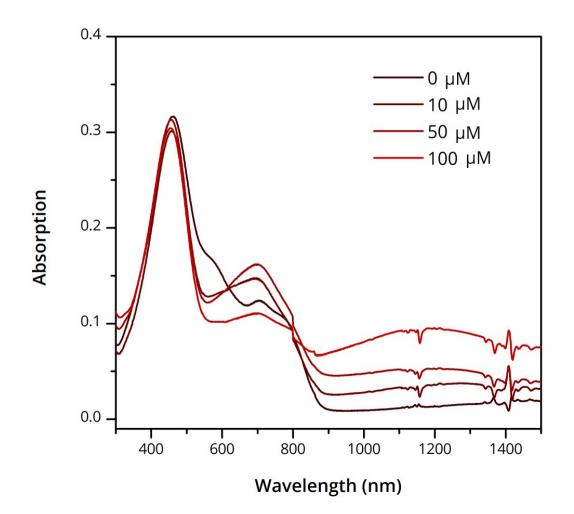


Figure S6. UV-Vis-NIR of Oxidized PTh_{80} -*b*-PTe₆₀. UV-Vis-NIR of PTh_{80} -*b*-PTe₆₀ with different concentrations of FeTs₃. All samples prepared at 0.05 mg/mL in 95 % DCM, 5 % chloroform.

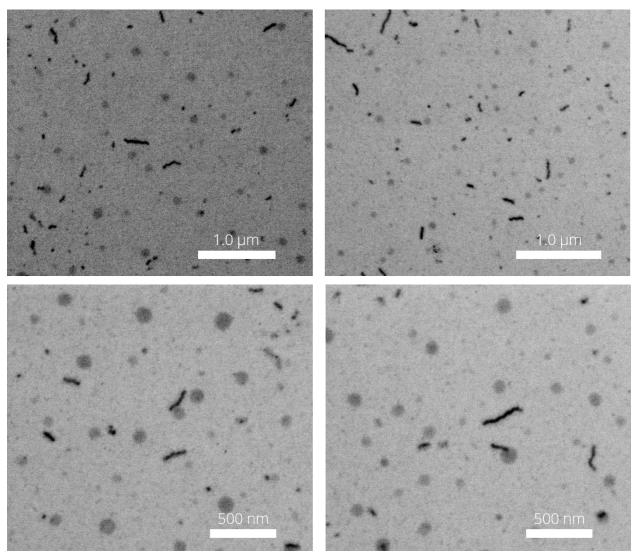


Figure S7. STEM of Partially Aggregated PTh_{80} -*b*-PTe₆₀. Partially aggregated PTh_{80} -*b*-PTe₆₀ drop-cast onto a carbon film with Cu support grid. STEM utilized to improve the visualization of low contrast unimer film, which appear as amorphous, circular features.

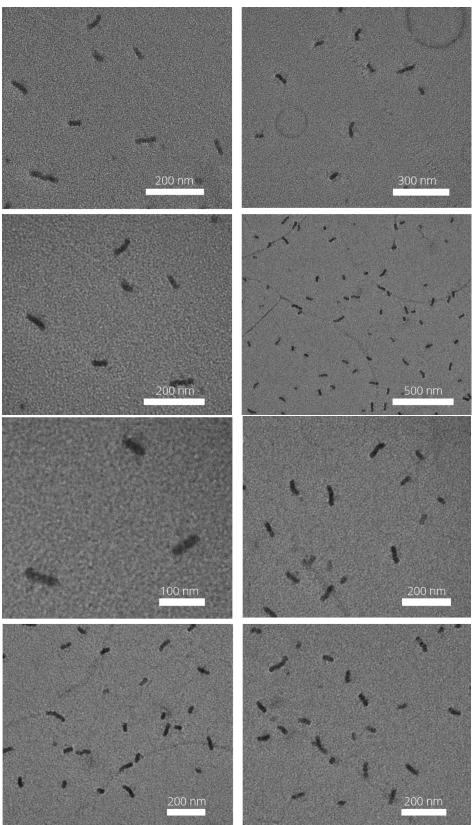


Figure S8. TEM of Oxidized PTh₈₀-*b*-PTe₆₀

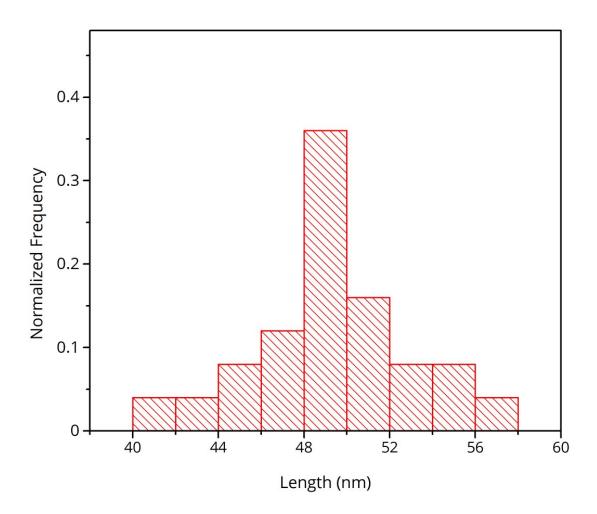


Figure S9. Oxidized PTh₈₀-*b*-PTe₆₀ Micelle Widths measured by AFM

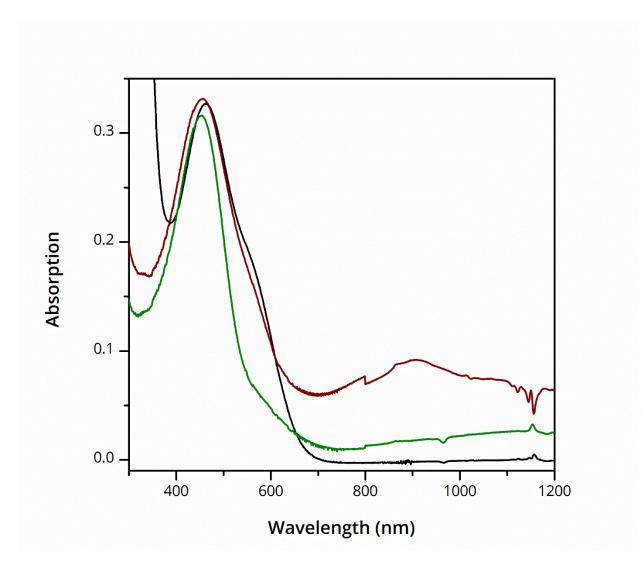


Figure S10. PTh_{80} -b- PTe_{60} 15 min after FeTs₃ addition in chloroform (green) and 95 % DCM, 5 % chloroform (red). Solvated PTh_{80} -b- PTe_{60} shown for reference (black).

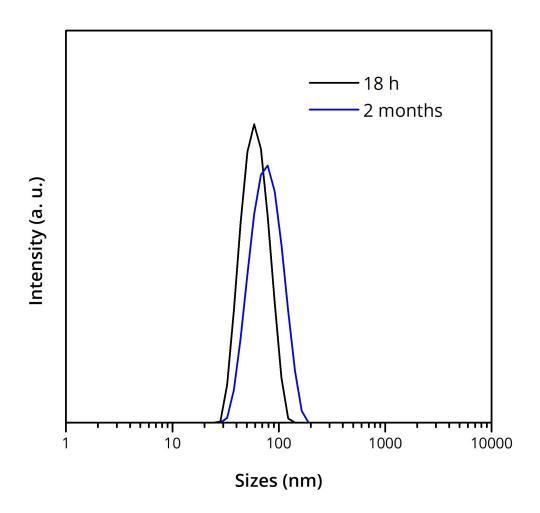


Figure S11. Size Distribution of Oxidized Micelles Aged for 2 months

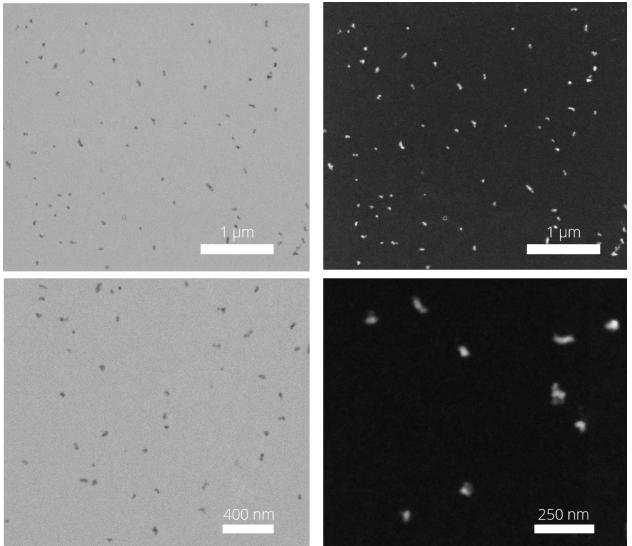


Figure S12. STEM of Oxidized Micelles Aged for 2 months. Oxidized micelles drop cast onto carbon film with Cu support grid after aging for 2 months. Bright field (left) and dark field (right) modes of STEM were used to visualize the sample, showing only oxidized micelles unchanged with aging.

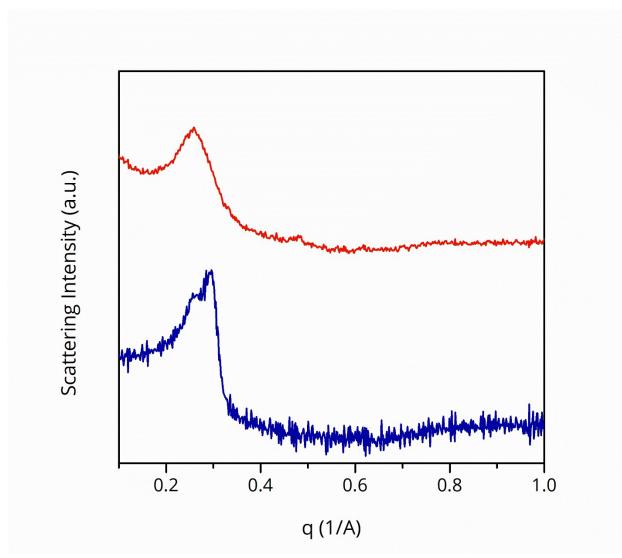


Figure S13. WAXS of Partially Aggregated (blue) and Oxidized PTh₈₀-*b*-PTe₆₀ (red) samples.

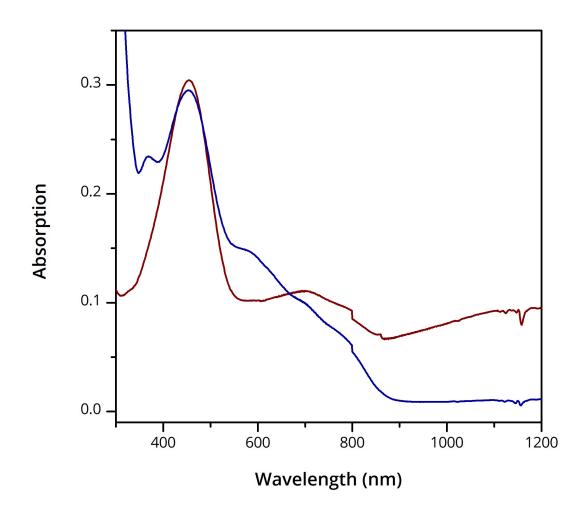


Figure S14. UV-Vis-NIR Spectroscopy of Oxidized (red trace) and Reduced PTh_{80} *b*-PTe₆₀ (blue trace).

S1. Work Function Calculation for Oxidatively Doped PTe Films

Difference in work function ($\Delta \varphi$) is an average of three measurements at different locations over two films. Films were scratched to expose the ITO to measure the contact potential difference (CPD) across the film surface and the CPD of the ITO surface using Kelvin probe force microscopy (KPFM). $\Delta \varphi$ is calculated using the equations below where *e* is elementary charge.

 $\Delta \varphi = \varphi_{doped film} - \varphi_{pristine film}$

where

$$CPD_{film} = \frac{\varphi_{film} - \varphi_{tip}}{e}$$

It should be noted that the CPD of the film is the relative difference of the CPD between the film surface and the CPD of the ITO surface. This difference is largely unaffected between measurements. Measuring the film surface without an ITO reference typically results in large differences in the CPDs of the film when measuring the same sample multiple times or when using different KPFM tips. Referencing the CPD of the film to the CPD of ITO eliminates this variability.

Concentration (mM)	Difference in Work Function (meV)	Conductivity (S cm ⁻¹)
1	240 ± 50	8.7 ± 3.4^{2}
5	340 ± 50	6.0 ± 0.6^{2}
10	400 ± 40	1.4 ± 0.4^{2}

Table S1. Differences in work function and conductivities of PTh_{80} -*b*- PTe_{60} thin films dip-doped with $FeTs_3$

References

- J. Liu, R. S. Loewe and R. D. McCullough, Employing MALDI-MS on Poly(alkylthiophenes): Analysis of Molecular Weights, Molecular Weight Distributions, End-Group Structures, and End-Group Modifications, *Macromolecules*, 1999, **32**, 5777–5785.
- J. R. Panchuk, A. W. Laramée, J. G. Manion, S. Ye and D. S. Seferos, Heavy atom substitution — A strategy for improving conductivity in conjugated polymers, *Synth. Met.*, 2019, 253, 57–61.